



BOX PATENT APPLICATION COMMISSIONER FOR PATENTS WASHINGTON, D.C. 20231



Transmitted herewith for filing is the continuing patent application of:

Inventor(s): Vishnu K. Agarwal, Garo Derderian, Gurtej S. Sandhu, Weimin M. Li, Mark

Visokay, Cem Basceri and Sam Yang

For: METHODS FOR FORMING AND INTEGRATED CIRCUIT STRUCTURES

CONTAINING RUTHENIUM AND TUNGSTEN CONTAINING LAYERS

		sed are:  12 pages of specification, 9 pages of claims, and an abstract 4 sheet(s) of drawings 3 pages of an Oath or Declaration				
15. 14.6 (17) 11.5 (1.8 15.	Continuing Application:  Continuation Divisional Continuation-in-part (CIP)		Information from Prior Application: Prior Application Number: 09/590,795 Examiner: Cuong Q. Nguyen Art Unit: 2811			
4	$\boxtimes$	Please enter the preliminary amendment prior to calculation of fees. The fee has been calculated as shown below.				

		FILING I	FEE			
	Claims	Number		Number		Basic Fee
For	Filed	allotted		Extra	Rate	\$740.00
Total Claims	9	20	=	0	\$18.00	\$ 0.00
Independent Claims	7	3	=	4	\$84.00	\$ 336.00
Multiple Dependent Clair				\$280.00		
TOTAL FILING FEE			-		\$1076.00	

$\boxtimes$	A check in the amount of \$1,076.00 to cover \infty filing fee and \infty assignment recordal fee
	is enclosed.

- Assignee for this application is or will be Micron Technology, Inc., and applicants request that this information be listed on the published application.
- The entire disclosure of the prior application, from which a copy of the oath or declaration is supplied, is considered to be part of the disclosure of the accompanying application and is hereby incorporated by reference herein.
- The Director is hereby authorized to charge any additional fees which may be required in connection with the filing of this application and recording any assignment filed herewith, or credit over-payment, to Account No. 02-4550. A copy of this sheet is enclosed.
- Please return the enclosed postcard to confirm that the items listed above have been received.

Respectfully submitted,

KLARQUIST SPARKMAN, LLP

Ву

Michael D. Jones

Registration No. 41,879

One World Trade Center, Suite 1600

121 S.W. Salmon Street Portland, Oregon 97204

Telephone: (503) 226-7391 Facsimile: (503) 228-9446

cc: Docketing

Client